

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Satoh et al.  
Appl. No. : 10/759,953  
Filed : January 16, 2004  
For : SEMICONDUCTOR-  
PROCESSING DEVICE  
PROVIDED WITH A REMOTE  
PLASMA SOURCE FOR SELF-  
CLEANING  
Examiner : Alejandro Mulero, Luz. L.  
Group Art Unit : 1763

## CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

August 18, 2006

(Date)

Eli A. Loots, Reg. No. 54,715

RESPONSE TO OFFICE ACTION**Mail Stop Amendment**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed on May 18, 2006, Applicants request that the above-captioned application be amended as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.